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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Young-Joon Park, et al.

Art Unit: 2814

Serial No.: 10/628,198

Examiner: Ginette Peralta

Filed: 07/28/03

Docket: TI-35623

For: A Two Step Semiconductor Manufacturing Process for Copper Interconnects

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is being deposited with
the U.S. Postal Service as First Class Mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450.

Karen Vertz 12-2-04
Karen Vertz Date

EXTENSION OF TIME

Pursuant to 37 CFR 1.136(a), Applicants respectfully petition the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

The fee for this extension is indicated below:

- ☒ First Month (\$110)
☐ Second Month (\$430)
☐ Third Month (\$980)
☐ Fourth Month (\$1,530)
☐ Fifth Month (\$2,080)

Please charge the fee to deposit account No. 20-0668 of Texas Instruments Incorporated. The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Account No. 20-0668. An original and two copies of this sheet are enclosed

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Respectfully submitted

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